

**Notice of References Cited**

Application/Control No.

10/053,704

Applicant(s)/Patent Under  
Reexamination  
HATTORI ET AL.

Examiner

Nguyen N Hanh

Art Unit

2834

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,274,960	08-2001	Sakai et al.	310/156.02
	C	US-			
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	F	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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